



Docket No.: 212761US99

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231



ATTORNEYS AT LAW

RE: Application Serial No.: 09/928,356

Applicants: Robert LEMPKOWSKI, et al.

Filing Date: August 14, 2001

For: STRUCTURE AND METHOD FOR FABRICATING
SEMICONDUCTOR STRUCTURES AND DEVICES
FOR DETECTING AN OBJECT

Group Art Unit: 2815

Examiner: BAUMEISTER

SIR:

Attached hereto for filing are the following papers:

**REQUEST FOR RECONSIDERATION
REQUEST FOR EXTENSION OF TIME (three-month)**

Our check in the amount of \$930.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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